

Notice of References Cited	Application/Control No. 10/612,438	Applicant(s)/Patent Under Reexamination HU ET AL.	
	Examiner SHANTELL HEIBER	Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,471,927	12-2008	Chen et al.	455/39
*	B	US-2004/0028006	02-2004	Kayama et al.	370/320
*	C	US-2003/0063588	04-2003	Lee et al.	370/335
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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